Attorney Docket No. 071469-0307692

Client Reference: RAJ-024

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re application of:

HONGYU YUE, WESLEY NATZLE

Application No.:

Confirmation

No:

Filed:

March 30, 2004

Group No.:

Examiner

For:

METHOD AND SYSTEM FOR PERFORMING A CHEMICAL OXIDE REMOVAL

PROCESS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

SUPPLEMENTAL APPLICATION DATA SHEET 37 C.F.R. § 1.76

BIBLIOGRAPHIC DATA

1. Applicant information

First applicant: HONGYU YUE

Citizenship: PEOPLES' REPUBLIC OF CHINA

Residence: Plano, TX 75025

Second applicant: WESLEY NATZLE

Citizenship: USA

Residence: New Paltz, NY 12561

2. Correspondence information

Correspondence for this application should be addressed as follows:

Customer No.: 00909

3. Application information

Title of Invention: METHOD AND SYSTEM FOR PERFORMING A CHEMICAL OXIDE REMOVAL PROCESS

Docket number assigned to this application: 071469-0307692

Suggested Classification:

Class:

Subclass:

Technology Center to which subject matter is assigned:

Total number of drawing sheets: 20

Type of application: Utility

Application is to be published. Suggested drawing figure for publication:

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

4. Representative information

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

5. Assignee information

The assignee(s) of this application is/are:

Tokyo Electron Limited 3-6, Akasaka 5-chome, Minato-ku Tokyo, 107 JAPAN Extent of interest of assignee in application: 50%

International Business Machines Corporation New Orchard Road Armonk, NY 10504 Extent of interest of assignee in application: 50%

Date: September 9, 2004

PILLSBURY WINTHROP LLP P.O. Box 10500 McLean, VA 22102 Customer No. 00909 Signature of Tractitioner Jeffrey Q. Karceski Registration No. 35,914 (703) 905-2110